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## **INFORMATION DISCLOSURE** STATEMENT BY APPLICANT

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Complete if Known				
Application Number	10/706,586			
Filing Date	11/12/2003			
First Named Inventor	John Brian Pendry			
Art Unit	2821			
Examiner Name				
Attorney Docket Number	8068	/		

		NON PATENT LITERATURE DOCUMENTS	
Examiner	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Τ²
Tp		Bessel Functions – Orders 3-9, Bessel Functions of Integer Order, Compiled from British Association for the Advancement of Science, Bessel functions, Part II. Functions of positive integer order, Mathematical Tables, vol. X (Cambridge Univ. Press, Cambridge, England, 1952) and Mathematical Tables Project, Table of In(s)=n!(1/2X)-  "J <sub>n</sub> (x). J. Math. Phys. 23, 45-60 (1944) (with permission).	
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